



In the United States Patent and Trademark Office

Applicant: BRIGHT et al.

Applicant's Ref: LAM2P318D

Application No: 10/722,839

Filed: November 25, 2003

Title: APPARATUS FOR CONTROLLING
 WAFER TEMPERATURE IN CHEMICAL
 MECHANICAL POLISHING

Examiner: G.B.M. Nguyen

Group Art Unit: 3723

Date: October 3, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 3, 2005.

Signed: _____

Kay Harlow

Separate Letter to the Official Draftsperson

Commissioner for Patents
 Mail Stop PGPUB Drawings
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Applicants are hereby submitting two sheets of Replacement Drawings (Figures 5A-5D and 6A-6C), for the above-referenced application. If the draftsperson has any questions concerning these drawings, please contact the undersigned at the number set forth below. If any fees are due in connection with the filing of these drawings, please charge such fees to deposit account 50-0805 (Order No. LAM2P318.DIV).

Respectfully submitted,

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